

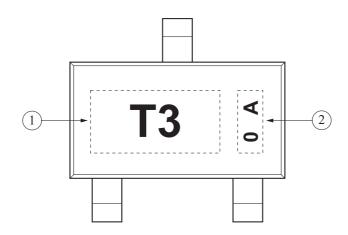
# **SEMICONDUCTOR**MARKING SPECIFICATION

## KDR531T TSM PACKAGE

### 1. Marking method

Laser Marking

### 2. Marking



No.	Item	Marking	Description
1)	Device Mark	Т3	KDR531T
2	* Lot No.	0A	2007. 1st Week [0:1st Character, 1:2nd Character]

Note) \* Lot No. marking method

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Year	Periode (Year)	Remark
01, 0251, 52	01 : 2006. 1st Week, 02 : 2006. 2nd Week  51 : 2006. 51th Week, 52 : 2006. 52th Week.	Rotation for 4 years: 0152:2006, 2010, 2014 0A5B:2007, 2011, 2015 J1E2:2008, 2012, 2016 JAEB:2009, 2013, 2017
0A, 0B5A, 5B**	0A: 2007. 1st Week, 0B: 2007. 2nd Week  5A: 2007. 51th Week, 5B: 2007. 52th Week.	
J1, J2E1, E2**	J1: 2008. 1st Week, J2: 2008. 2nd Week  E1: 2008. 51th Week, E2: 2008. 52th Week.	
JA, JBEA, EB**	JA: 2009. 1st Week, JB: 2009. 2nd Week  EA: 2009. 51th Week, EB: 2009. 52th Week.	